

WHAT IS CLAIMED IS:

1. A pattern formation member adopted to  
a sectioning image observation apparatus which  
selectively irradiates a light from a light source to  
5 a sample, scans said sample, and acquires a light from  
said sample as a sectioning image, wherein

said pattern formation member comprises  
an irradiation section and a cutoff section,

each of said irradiation section and said cutoff  
10 section is in a straight pattern, and

these straight patterns are disposed  
alternatively.

2. The pattern formation member according to  
claim 1, wherein

15 said pattern formation member is a rotation disk  
such that said irradiation section is a translucent  
section to pass a light and said cutoff section is  
a shield section to shield a light,

said rotation disk is rotated on a light path,  
20 each of patterns to scan said sample by the  
light passing through said rotation disk is formed in  
a straight pattern, and

these patterns are disposed alternatively.

3. The pattern formation member according to  
25 claim 1, wherein

a width of the straight pattern of said shield  
section is larger than that of said translucent

section.

4. The pattern formation member according to claim 1, wherein

5 said pattern formation member is a digital micro mirror having a plurality of mirrors, whose directions are independently changeable, disposed in a two-dimensional form.

10 5. A pattern formation member, according to claim 3, wherein said rotation disk is divided into a plurality of areas and a pattern of each of said plurality of areas is different.

6. The pattern formation member according to claim 5, wherein

15 said plurality of areas are located on concentric circles and each of them has different straight patterns.

20 7. A sectioning image observation apparatus which scans a sample with a light by using a pattern formation member described in claim 1, and acquires a reflected light from said sample as a sectioning image through said pattern formation member.

25 8. The sectioning image observation apparatus according to claim 7, further comprising a moving mechanism to change projection position on said rotation disk to said sample.

9. A sectioning image observation apparatus which enters an excited light with a predetermined wavelength

through an excitation filter to a pattern formation member described in claim 1, scans a sample with a light by using said pattern formation member, and acquires a fluorescence emitted from said sample as a sectioning image through said pattern formation member and a barrier filter selecting a wavelength of the emitted fluorescence.

10. A sectioning image observation apparatus comprising:

10 a light source;

a rotation disk having a pattern in which a slit translucent section which passes a light and a straight shading section which shields a light, are alternately and periodically arranged;

15 means to lead a light from said light source to said rotation disk;

means to irradiate a light passing said rotation disk to a sample and project a pattern of said rotation disk to the sample;

20 an optical lens which projects a light reflected from said sample on said rotation disk; and

means to rotate said rotation disk on an optical path, scan the pattern of said rotation disk projected on the said sample, and acquires an image passing said rotation disk as an sectioning image among sample images projected on said rotation disk, wherein

when an angle of said rotation disk surface and  
a surface normal to an optical axis is  $\theta$ , an aperture  
of said lens from said sample is NA, an expansion rate  
of a sample image projected on said rotation disk is M,  
5 a diameter (called as a number of view) on said  
rotation disk in an area of the observed sample is R,  
an angle between a main light beam which passes at an  
outermost edge of a diameter on said rotation disk of  
the observed sample area and an optical axis is  $\phi$ , and  
10 a wavelength of the light is  $\lambda$ , at least one of the  
following conditions are satisfied:

$$\theta > \phi + 2NA/M, \text{ and}$$

$$\theta < \frac{M^2 \lambda}{NA^2 R}.$$

11. The pattern formation member according to  
claim 2, wherein

a shield area is formed at a portion to which  
straight patterns of said translucent section and said  
20 shield section of said rotation disk is parallel to a  
scanning direction according to a rotation of said  
rotation disk in an observation field.

12. The pattern formation member according to  
claim 5, wherein

25 said plurality of areas have a plurality of sector  
shaped areas divided in a circumferential direction of  
said rotation disk.

13. The pattern formation member according to

claim 5, wherein

said plurality of divided areas are different  
direction areas of the straight patterns having  
different direction of said translucent section and  
5 said shield section not to be parallel to a scanning  
direction according to a rotation of said rotation disk  
in an observation field.

14. The pattern formation member according to  
claim 13, wherein

10 said different direction areas have a plurality of  
sector shaped areas each having a predetermined central  
angel, and

the straight pattern in said different direction  
areas are another straight pattern area of said  
15 translucent section and said shield section with sector  
shape area.

15. The pattern formation member according to  
claim 13, wherein

each of said different direction areas has a  
20 predetermined width, and

the straight patterns in each of said different  
direction areas are straight patterns of said  
translucent section and said shield section having  
different direction from the straight pattern of the  
25 other areas.

16. The pattern formation member according to  
claim 6, wherein at least two patterns of said

plurality of areas have patterns having different ratios of a width of said shield section and that of said translucent section.

17. The pattern formation member according to  
5 claim 16, wherein

a width of a straight portion of said translucent section is substantially constant.

18. The pattern formation member according to  
claim 17, further comprising

10 a plurality of areas having different direction of said translucent section and said shield section of the straight pattern of said rotation disk.

19. The pattern formation member according to  
claim 18, further comprising different direction areas  
15 on portions parallel to a scanning direction according to a rotation of said rotation disk in an observation field in the straight patterns, wherein

the straight patterns in each of said different  
direction areas are straight patterns of said  
20 translucent section and said shield section having different direction from the straight pattern of the other areas.

20. The pattern formation member according to  
claim 19, wherein

25 when a width of different direction area having a constant width is X and a period of said translucent section and said shield section is W in said rotation

disk,  $X/W$  is constant.

21. The pattern formation member according to claim 20, wherein

when said translucent section of said least two  
5 concentric circle areas have a same width and a period  
 $W$  of said translucent section and said shield section  
is different,

a period  $W$  of said translucent section and said  
shield section on an inner concentric circle area is  
10 smaller than that of an outer concentric circle area,  
and

a width  $X$  of a different direction area of inner  
and outer concentric circle areas is proportional to  
the period  $W$ .

22. The pattern formation member according to  
15 claim 6, wherein

at least two pattern of said plurality of areas  
have an equal ratio of a width of said translucent  
section and that of said shield section, and widths of  
20 said translucent section and said shield section are  
different for each of said areas.

23. The pattern formation member according to  
claim 22, further comprising different direction areas  
on portions parallel to a scanning direction according  
25 to a rotation of said rotation disk in an observation  
field in the straight patterns, wherein

the straight patterns in each of said different

direction areas are straight patterns of said translucent section and said shield section having different direction from the straight pattern of the other areas.

5           24. The pattern formation member according to claim 23, wherein

          when a width of different direction area having a constant width is X and a period of said translucent section and said shield section is W in said rotation disk, X/W is constant.

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          25. The pattern formation member according to claim 24, wherein

          at least two areas in which said translucent section and said shield section have same width are located so that a period W of said translucent section and said shield section on an inner concentric circle area is smaller than that of an outer concentric circle area, and

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          a size of the width of different direction area in the inner concentric circle areas is smaller than a size of the width of different direction area in the outer concentric circle areas.

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